	App	Application No. Applicant(s)		
	08/9	75,940	COMMINS ET AL.	
Notice of Allowabilit	<u> </u>	miner	Art Unit	
	Lanr	na Mai	3637	
The MAILING DATE of this co. All claims being allowable, PROSECUTION O herewith (or previously mailed), a Notice of All NOTICE OF ALLOWABILITY IS NOT A GRA of the Office or upon petition by the applicant.	N THE MERITS IS (OR For ownce (PTOL-85) or othe NT OF PATENT RIGHTS	REMAINS) CLOSED in the series of the series	in this application. If not includ nunication will be mailed in due	led course. THIS
1. This communication is responsive to O	<u>ct 20, 05</u> .			
2. The allowed claim(s) is/are <u>36-47</u> .				
 Acknowledgment is made of a claim for a)	rity documents have been rity documents have been es of the priority document Rule 17.2(a)). E "MAILING DATE" of this esult in ABANDONMENT of	received. received in Application to file	on No ed in this national stage applica	
4. A SUBSTITUTE OATH OR DECLARATINFORMAL PATENT APPLICATION (F	TION must be submitted. IPTO-152) which gives reas	son(s) why the oath o		NOTICE OF
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.				
(a) Including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached				
1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of				
Paper No./Mail Date				. h l
Identifying indicia such as the application no each sheet. Replacement sheet(s) should be	, , , , , , , , , , , , , , , , , , , ,		- · · · · · · · · · · · · · · · · · · ·	е раску от
6. DEPOSIT OF and/or INFORMATIO attached Examiner's comment regarding	•			Note the
Attachment(s) 1. Notice of References Cited (PTO-892)			nformal Patent Application (PT	O-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		6. Interview Summary (PTO-413), Paper No./Mail Date		
3. M Information Disclosure Statements (PTO-1449 or PTO/SB/08),		·	s Amendment/Comment	
Paper No./Mail Date 4. Examiner's Comment Regarding Require of Biological Material SUPERVISOR	ement for Deposit ANNA MAI RY PATENT EXAMINER	8.	s Statement of Reasons for All	owance
TECHNOL	OGY CENTER 3600			